

## PATENT APPLICATION

*JPAW*

Applicants : Yuji AKIMOTO et al

Title : METHOD FOR MANUFACTURING METAL POWDER

Serial No. : 10/657 569 Group: 1742

Confirmation No.: 9860

Filed : September 8, 2003 Examiner: Wyszomierski

Attn. Docket No.: Komatsu Case 293

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

## FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on April 25, 2005.


 Terryence F. Chapman

TFC/smd

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Correspondence: Information Disclosure Statement  
 dated April 25, 2005  
 including enclosures listed thereon

190.05/03

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IN THE U.S. PATENT AND TRADEMARK OFFICE

April 25, 2005

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## INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of the European Patent Office Search Report, Form PTO-1449 and the references cited thereon. The relevance of these references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Further consideration is respectfully solicited.

Respectfully submitted,

  
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Terryence F. Chapman

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Encl: Copy of European Patent Office Search Report  
dated January 26, 2005 (3 pages)  
Form PTO-1449 and references cited thereon  
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INFORMATION DISCLOSURE CITATION	Applicant: Yuji AKIMOTO et al Ser.No. : 10/657 569 Filed : September 8, 2003 Conf. No.: 9860 Atty.Ref.: Komatsu Case 293 Group : 1742
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date
	AA 5 852 768	12/1998	JACOBSEN et al			
	AB 5 928 405	7/1999	RANADE et al			
	AC 5 439 502	8/1995	KODAS et al			
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation Yes	Translation No
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AL	EP 1 151 817	11/2001	Europe			
AM						
AN						
AO						
AP						

## OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

AR	
AS	

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.